

# Prototype Setting for Elastic Matching-Based Image Pattern Recognition

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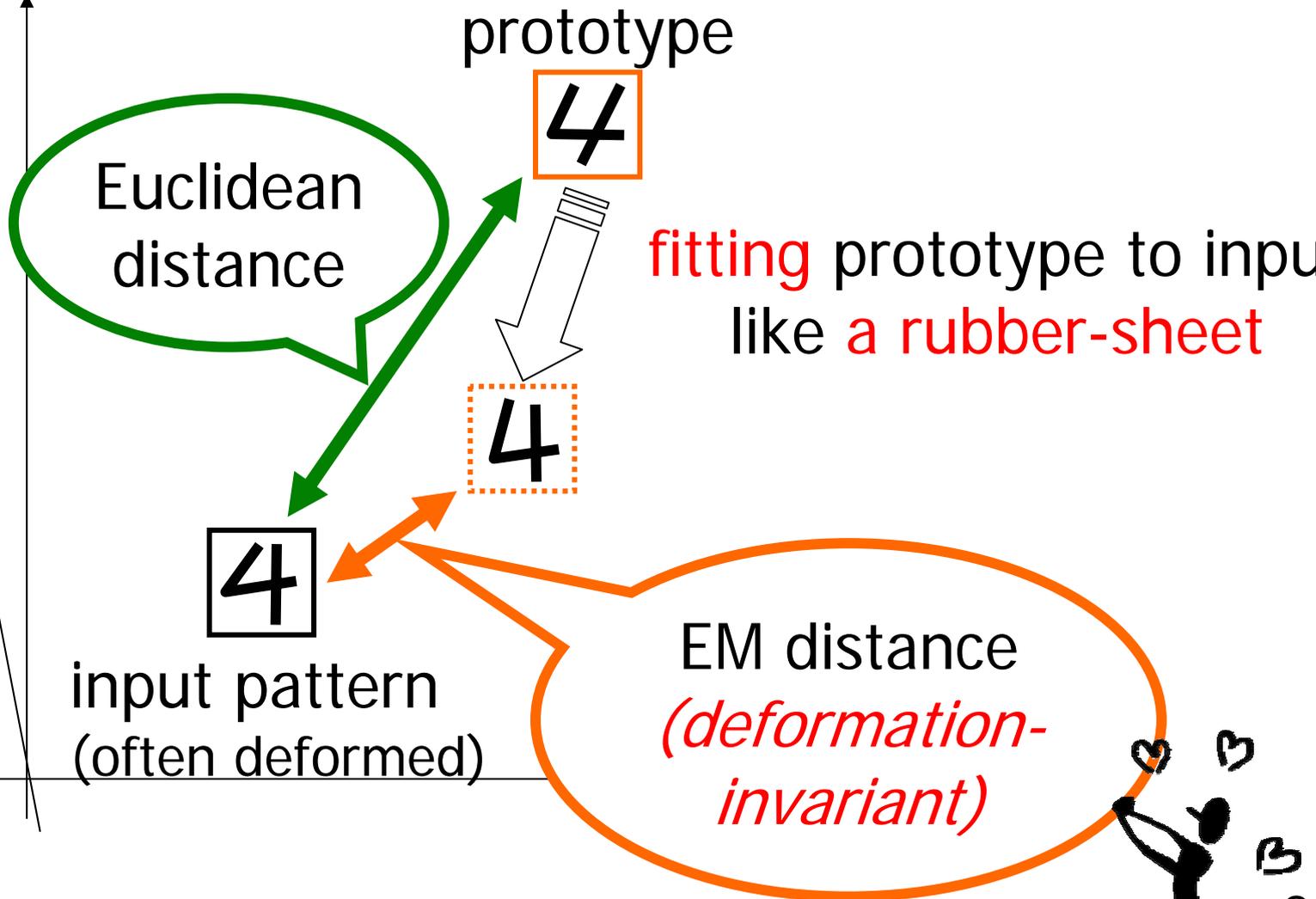
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# What is Elastic Matching (EM)?

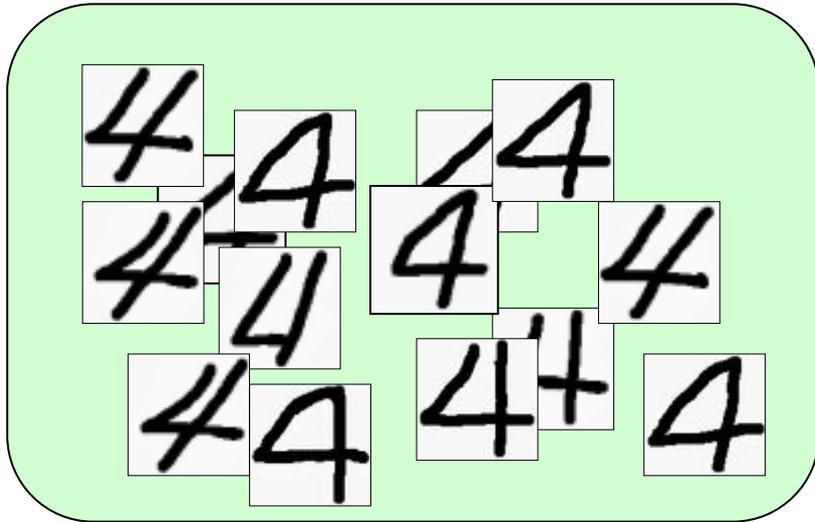
image  
pattern  
space



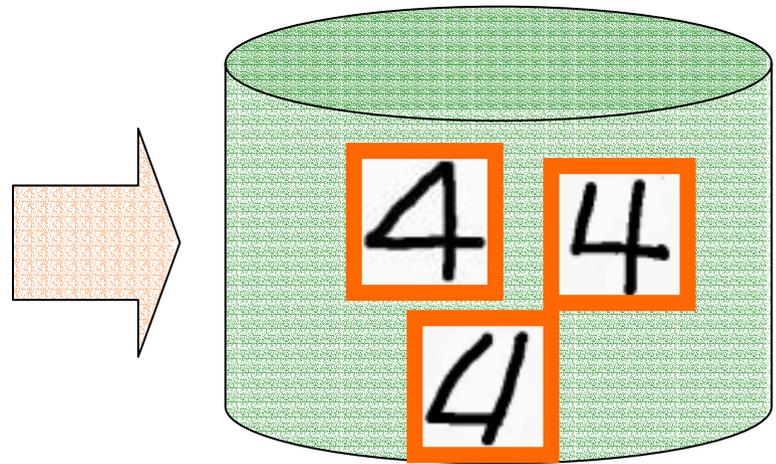
# Our Task

- Set reasonable prototypes for EM-based recognizer

training patterns



prototypes  
(representative patterns)



# How about Clustering ?

- It seems the most **promising** way !
  - Because clustering is widely used to set prototypes for various recognizers



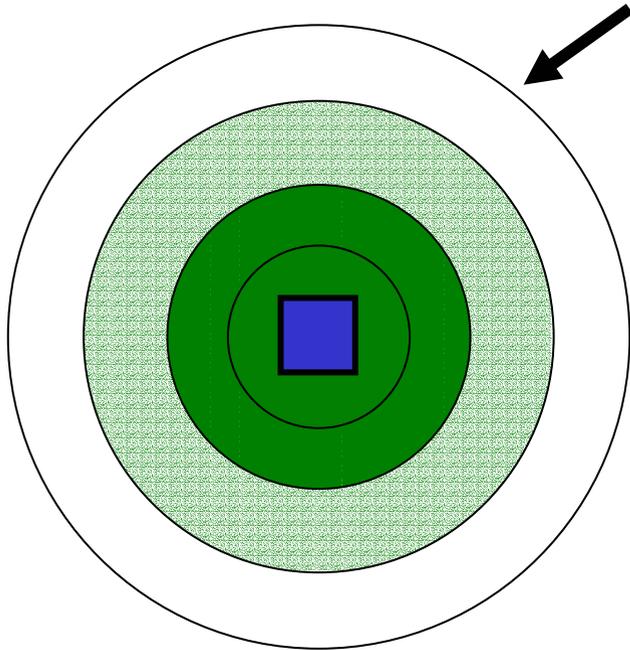
However,

- **Conventional** clustering techniques are **not suitable** for EM recognizer
  - Because they use *Euclidean distance* as their criteria

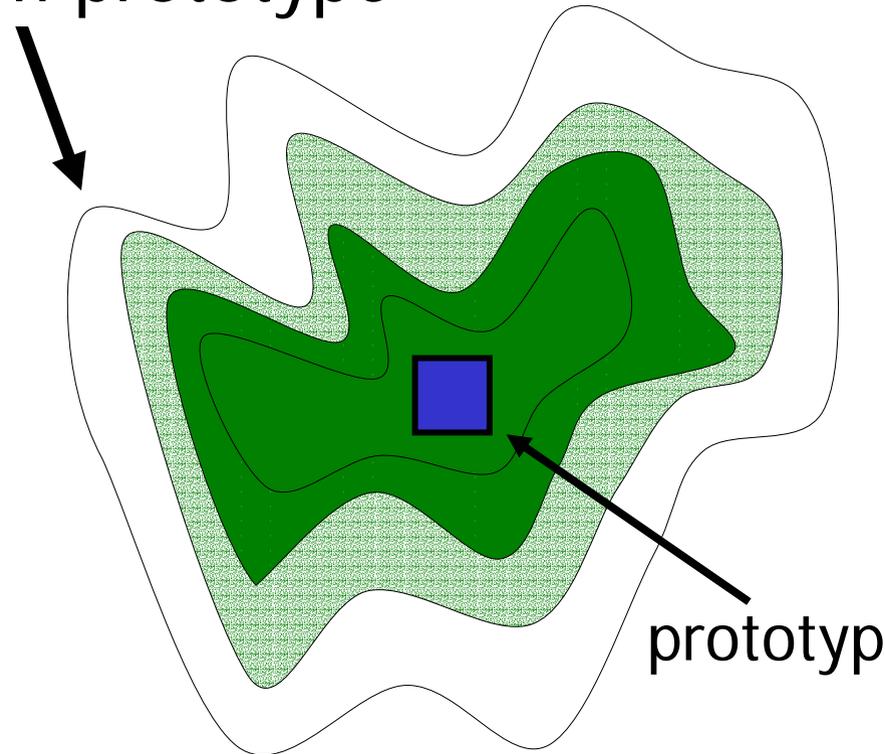


# Euclidean Dist. vs. EM Dist.

equidistant from prototype



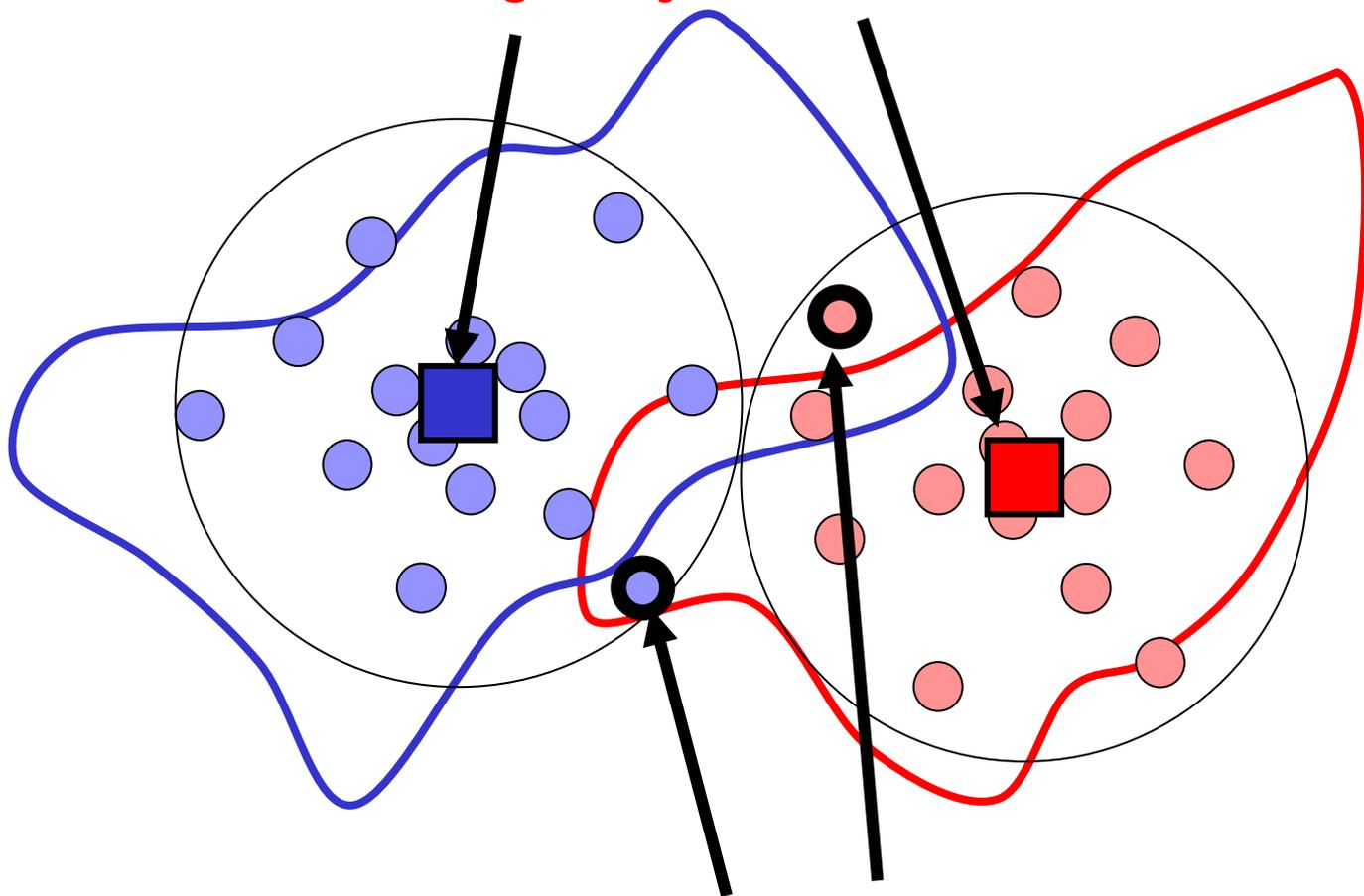
Euclidean dist. = isotropic



EM dist. = **not** isotropic

# Problem of Conventional Clustering

Prototypes set by conventional clustering  
(center of gravity in Euclidean sense)

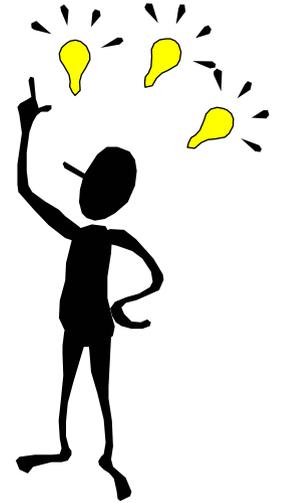


Patterns to be **misrecognized** by EM distance



# Our Purpose

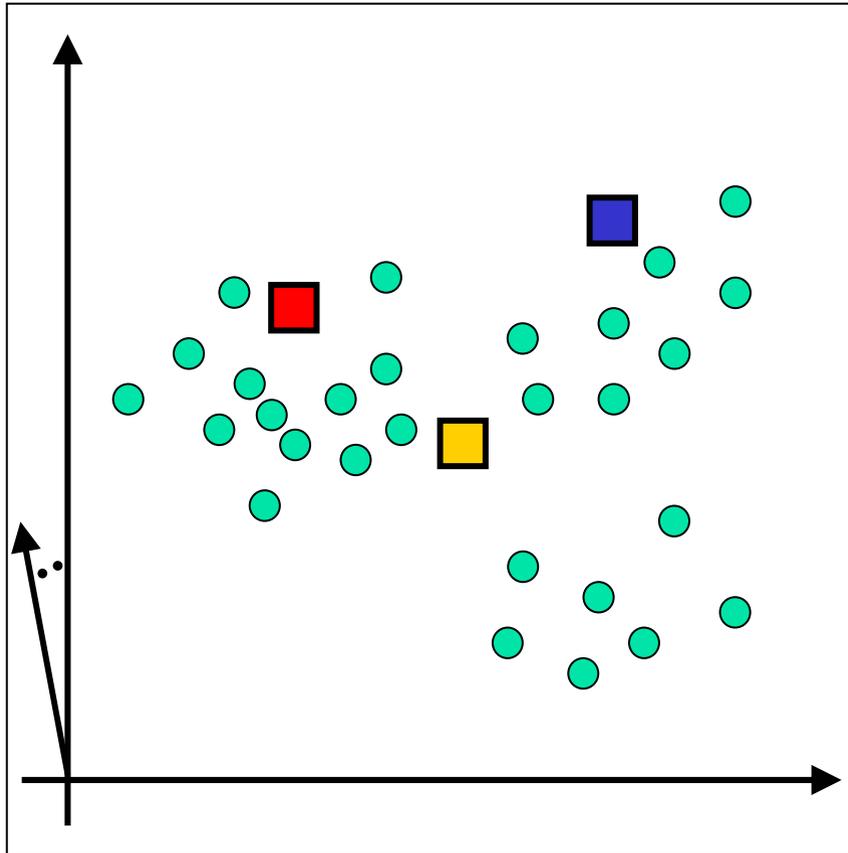
- Modify conventional clustering techniques to use *EM distance* as their criteria (instead of Euclidean distance)



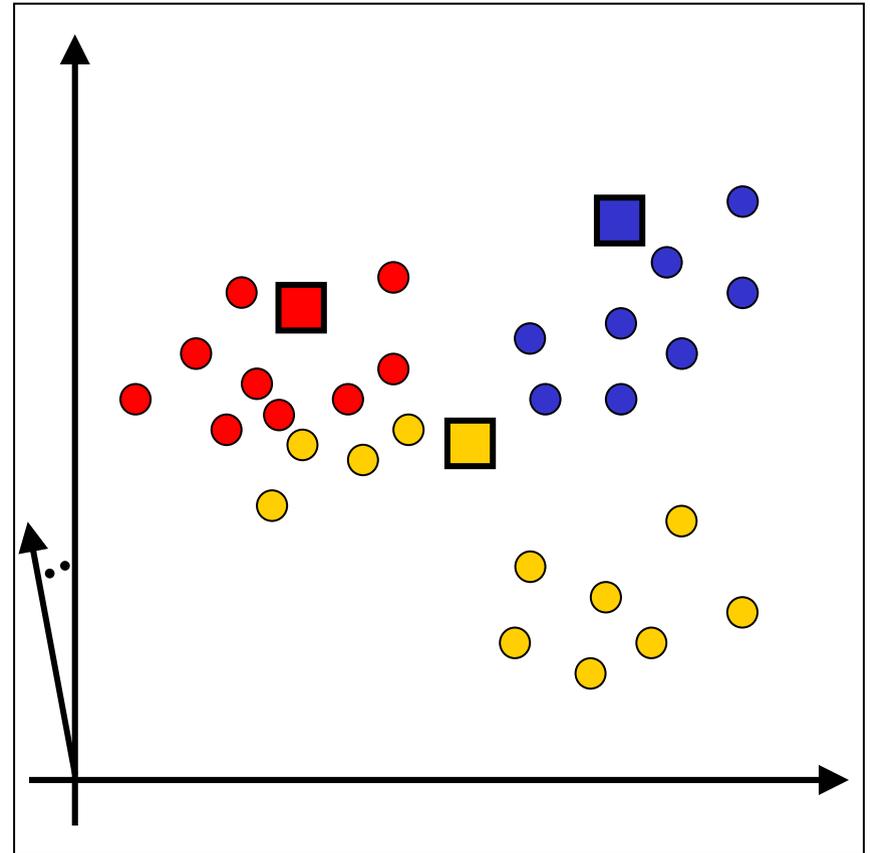
- For example, modify
  - K-means algorithm, and
  - Generalized learning vector quantization (GLVQ)

# K-means Modified for EM (1)

Step1: Initialize

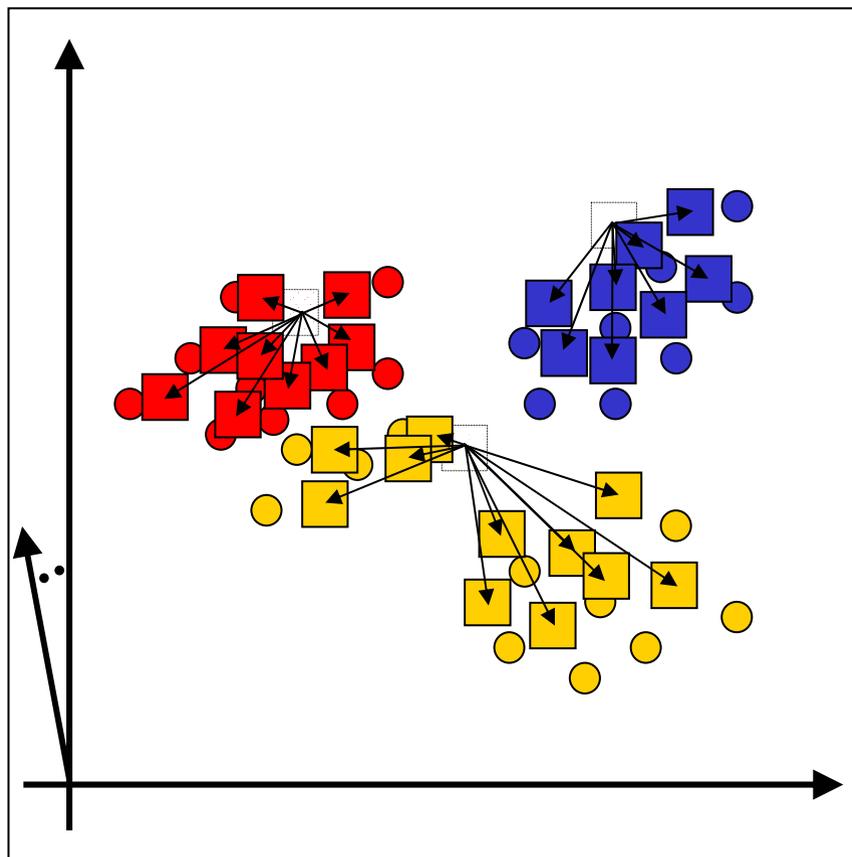


Step2: Partition by  
EM distance

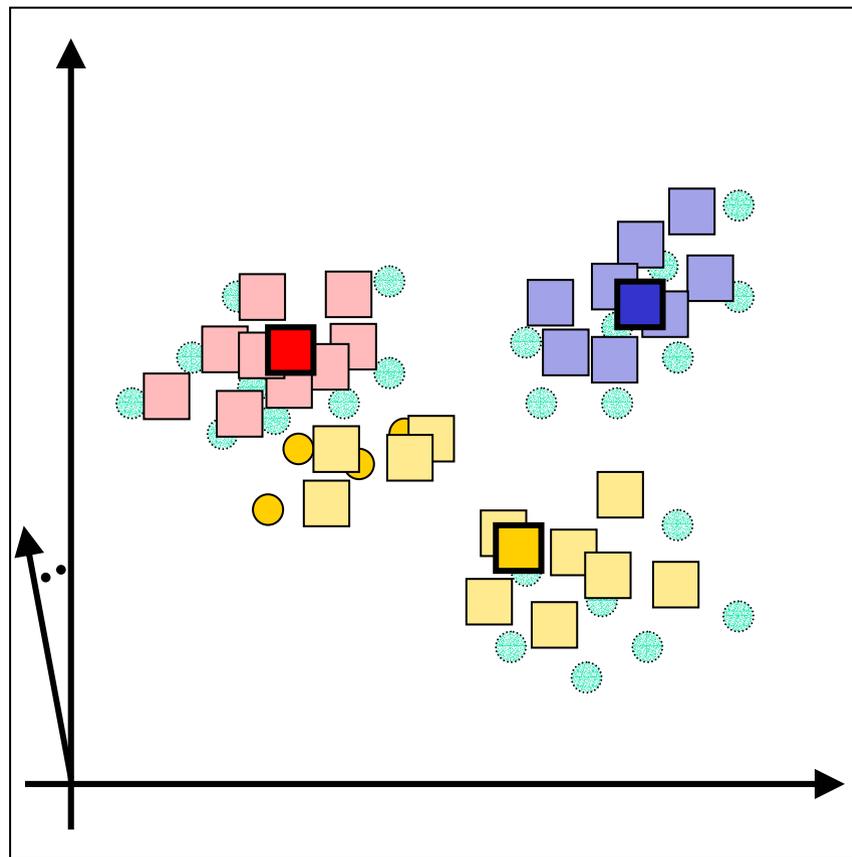


# K-means Modified for EM (2)

Step3: Fit to each training patterns by EM



Step4: Update prototypes by taking average



Back to Step 2

# Derivation of the Algorithm

Minimize  $J_{EM} = \sum_k \sum_{T_l \in C_k} \underline{D_{EM}(T_l, R_k)}$

NOTE:  $D_{EM}$  includes the optimization problem of EM

w.r.t. partitioning  $\{C_k\}$  and prototypes  $\{R_k\}$ ,

where

$\{T_l\}$  are training patterns, and

$D_{EM}(T_l, R_k)$  is EM distance between  $T_l$  and  $R_k$ .

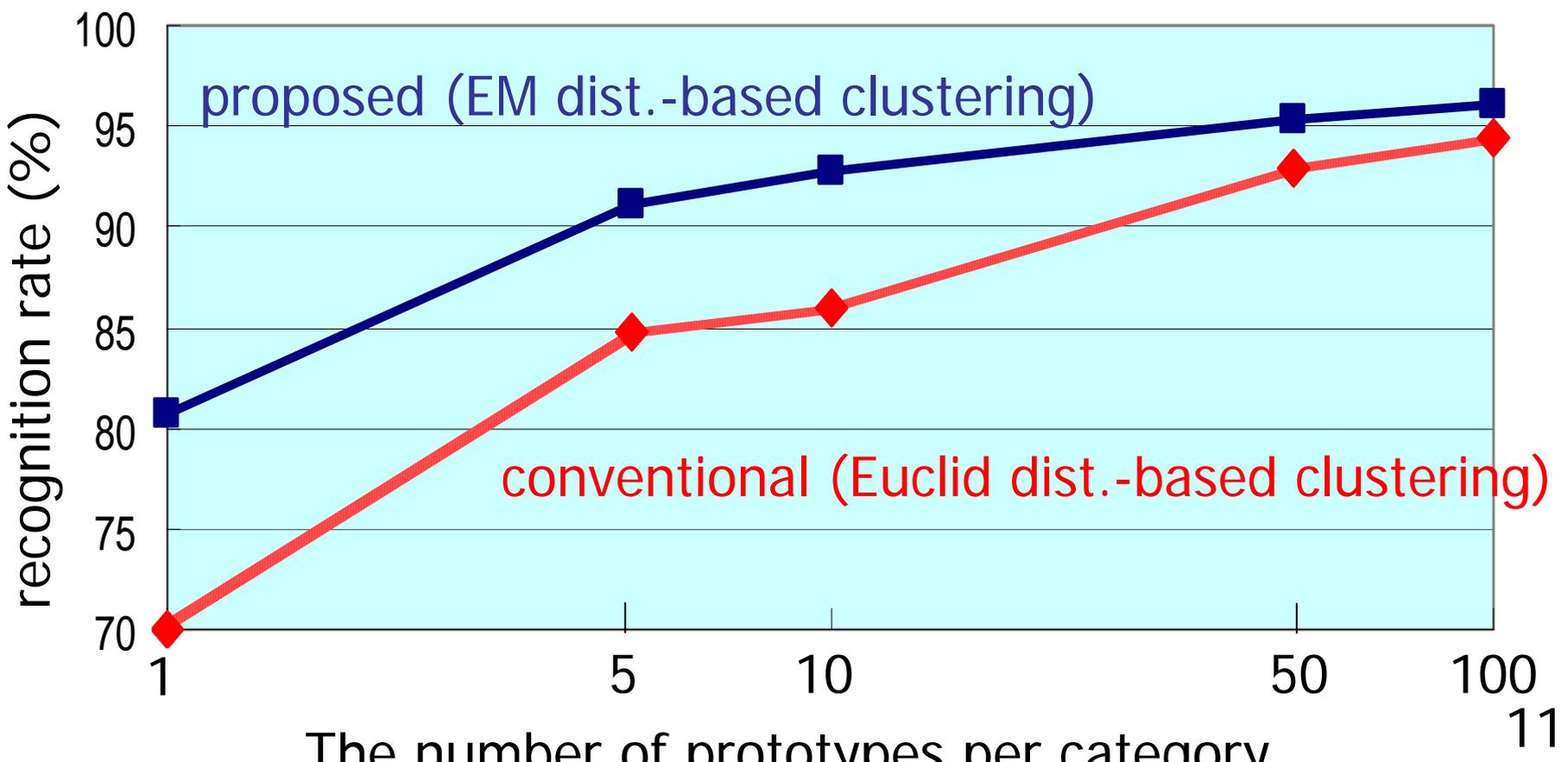
Iterative solution

Optimize  $\{C_k\}$  and EM with fixed  $\{R_k\}$  → Step 2

Optimize  $\{R_k\}$  with fixed  $\{C_k\}$  and EM → Step 3 & 4

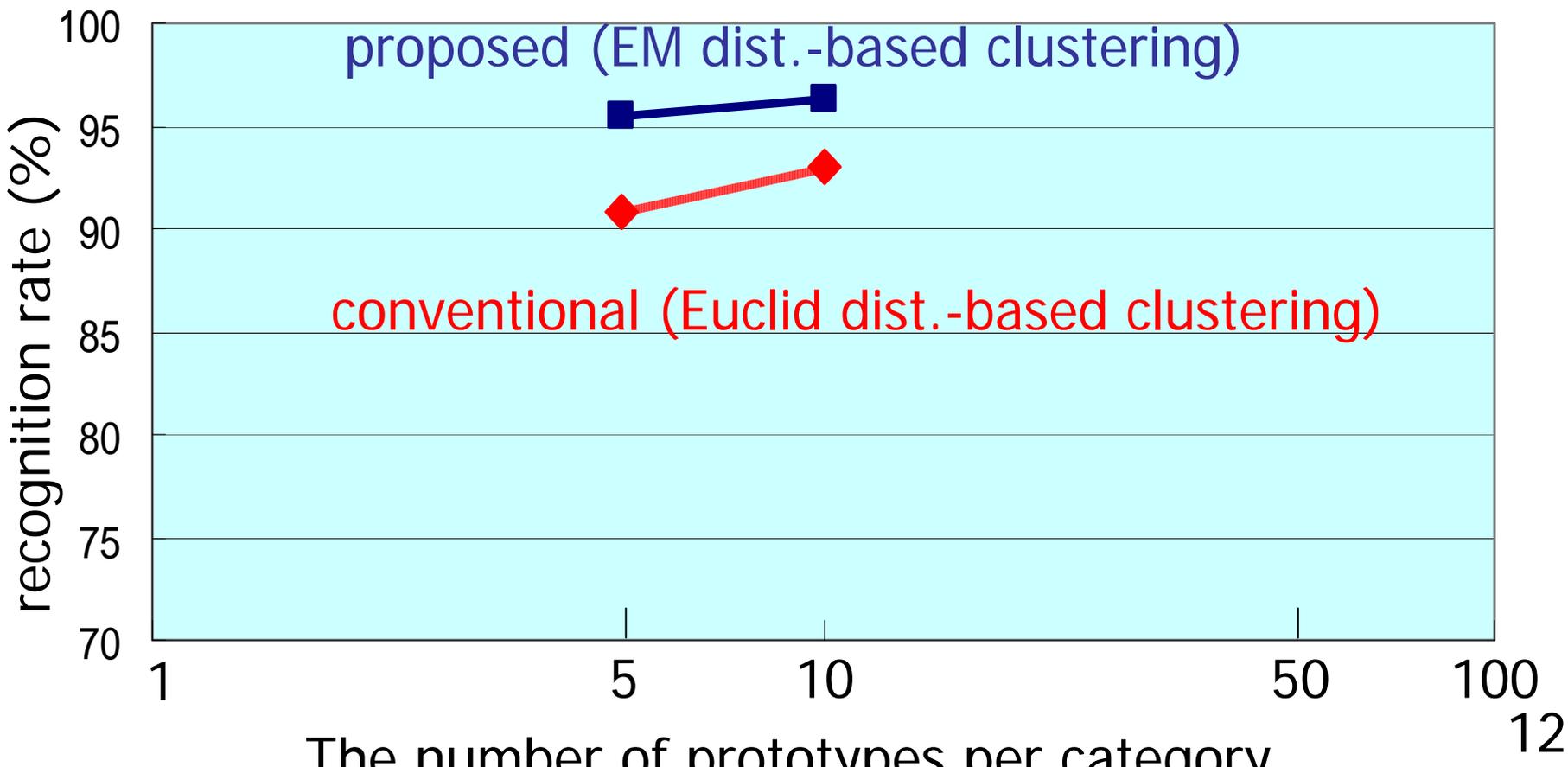
# Recog. Rate by Modified K-means

- 10 categories of **handwritten numerals** from MNIST database
- 60,000 training patterns and 10,000 test patterns
- 97.9% when all training patterns are used as prototypes



# Recog. Rate by Modified GLVQ

- GLVQ= A clustering technique where a Euclidean distance-based minimum classification error (MCE) criterion is used

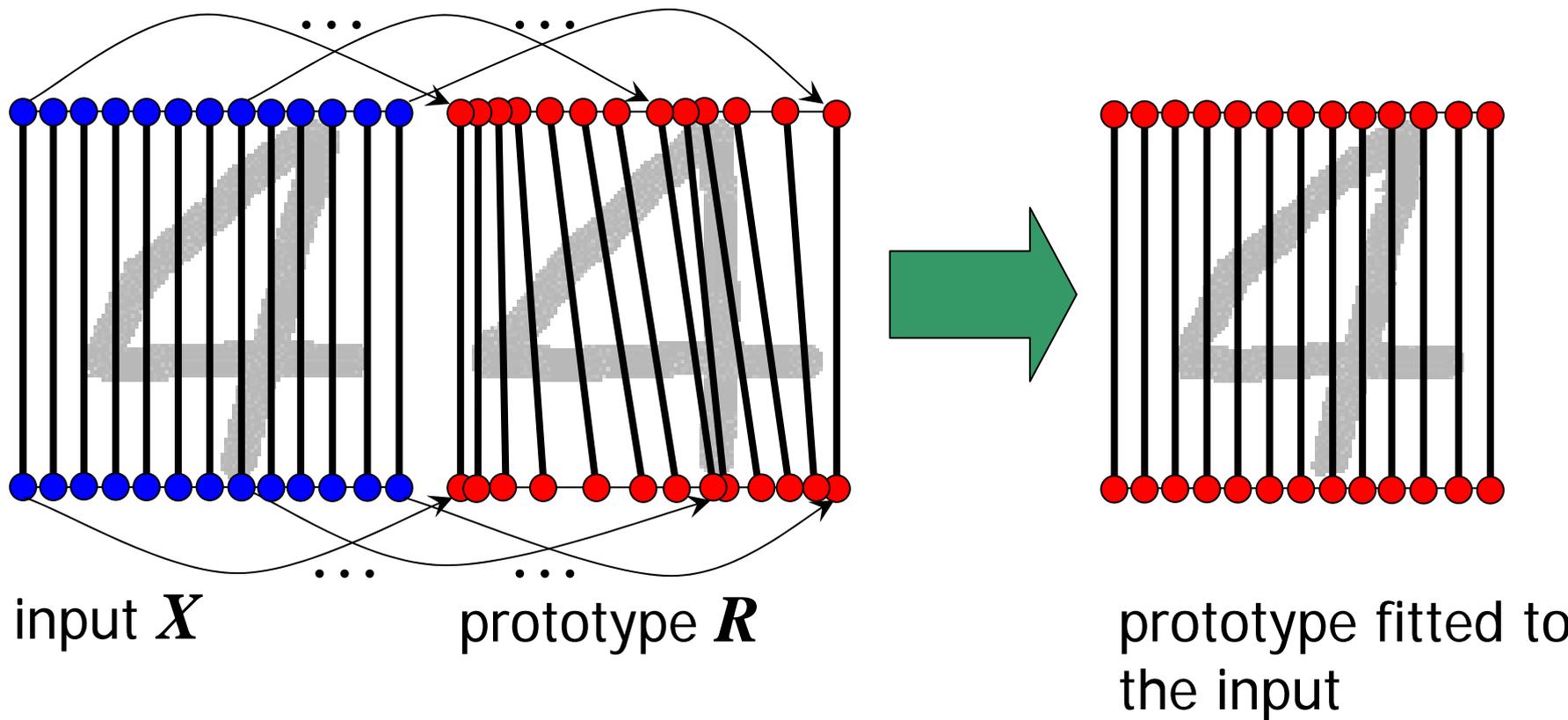


# Conclusion

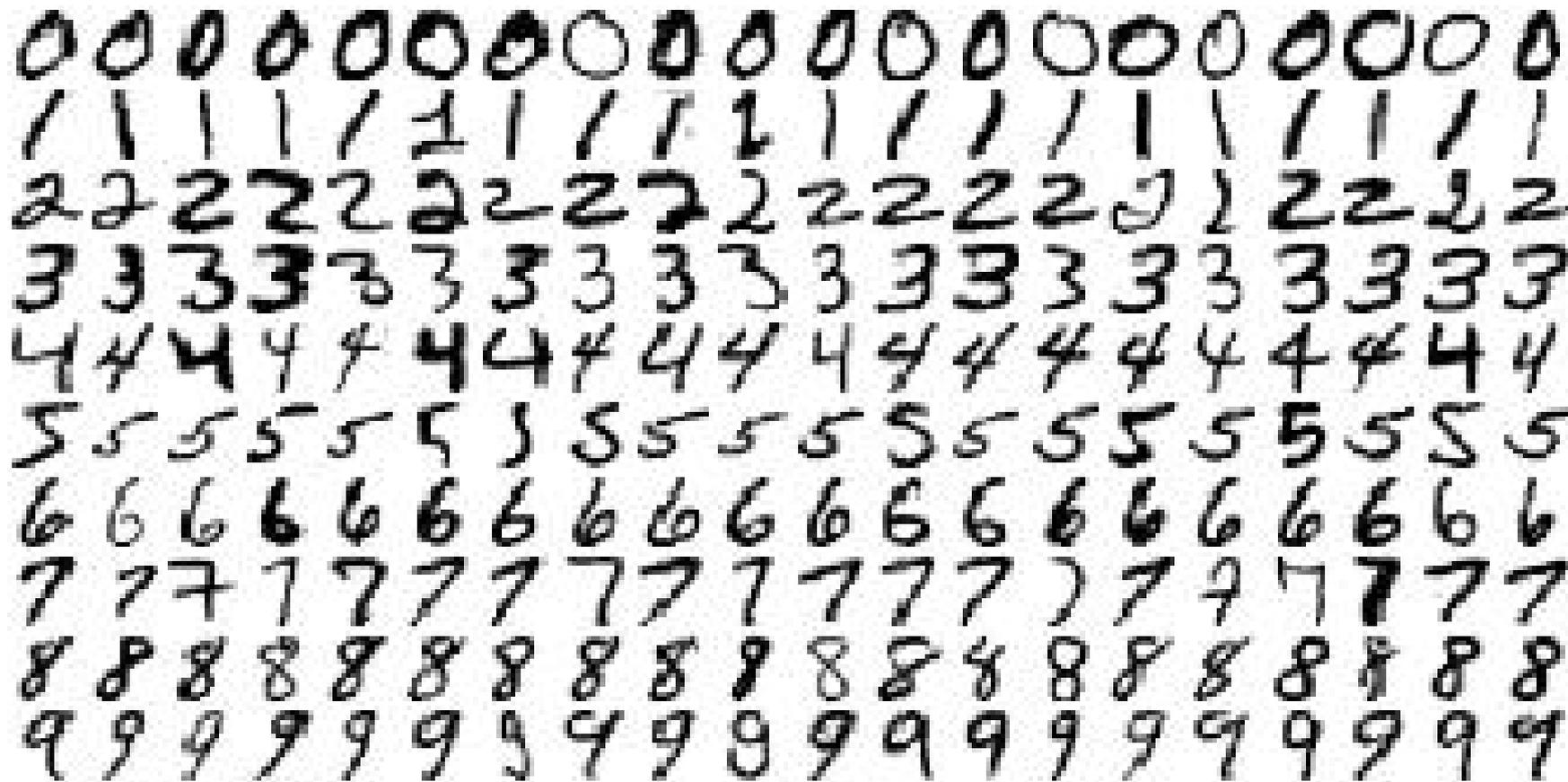
- For setting prototypes of EM-based recognizer conventional clustering techniques were modified to use EM distance as their criteria
- Experimental results showed that **the same EM distance must be used at prototype setting and recognition**

# The EM Used in Our Experiment

piecewise linear fitting (warping) function



# Samples in MNIST



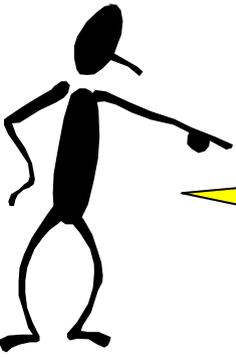
Recognition rates reported in literatures: 88 – 99.3%

# Our Main Conclusion

Distance metric at  
prototype setting

=

Distance metric at  
recognition  
(discrimination)



should be the same!